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Optimization of acoustic coupling for bottom actuated scattering based subsurface scanning probe microscopy

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Abstract

The characterization of buried nanoscale structures non-destructively is an important challenge in a number of applications, such as defect detection and metrology in the semiconductor industry. A promising technique is Subsurface Scanning Probe Microscopy (SSPM), which combines ultrasound with Atomic Force Microscopy (AFM). Initially, SSPM was used measure the viscoelastic contrast between a subsurface feature and its surrounding medium. However, by increasing the ultrasonic frequency to >1 GHz, it has been shown that SSPM can also measure acoustic impedance based contrasts. At these frequencies it becomes difficult to reliably couple the sound into the sample such that the AFM is able to pick up the scattered sound field. The cause is the existence of strong acoustic resonances in the sample, the transducer and the coupling layer – the liquid layer used to couple the sound energy from the transducer into the sample - in combination with the nonlinearity of the tipsample interaction. Thus, it is essential to control and measure the thickness of the coupling layer with nanometer accuracy. Here, we present the design of a mechanical clamp to ensure a stable acoustic coupling. Moreover, an acoustic method is presented to measure the coupling layer thickness in realtime. Stable coupling layers with thicknesses of 700 ± 2 nm were achieved over periods of 2–4 hours. Measurements of the downmixed AFM signals showed stable signal intensities for >1 hour. The clamp and monitoring method introduced here makes scattering based SSPM practical, robust and reliable and enables measurement periods of hours.

Introduction

The non-destructive characterization of buried nanoscale structures is an important challenge in different application areas. For the semiconductor industry application examples are buried defect detection ¹, lithography mask inspection ², and metrology ³. In the application of biomedical diagnostics example applications are the imaging of the internal structures of cells and tissues ⁴. A promising method is Subsurface Scanning Probe Microscopy (SSPM), which combines ultrasound with Atomic Force Microscopy (AFM). This technique has been shown to be capable of imaging buried nanostructures in various samples ^{5 6 7 8}. Two different contrast mechanisms have been identified for SSPM in the literature:

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1) Viscoelasticity 9 10 11 12 13:

Here, the contrast is caused by the variation in the stress-field induced in the sample by the tip of the cantilever and the ultrasound field, due to local viscoelasticity changes in the sample (e.g. due to the presence of a subsurface feature). The ultrasound excitation typically has frequencies of 1-100 MHz. In this regime wave propagation does not play a role; instead the ultrasound only serves to modulate the tip sample contact and thereby to excite the cantilever. Viscoelasticity based SSPM requires large indentation forces applied to the tip in order to extend the stress field in the sample and in that way probe the subsurface. Thus, the maximum detection depth of the method is limited to less than $1 \, \mu m^{8,12}$ depending on the medium's compressive strength and the viscoelastic contrast between the subsurface feature and the surrounding medium.

2) Scattering 14 15:

Here, the contrast is caused by acoustic scattering due to differences in the acoustic impedance between buried features and the rest of the sample. Thus, the contrast depends on the stiffness and density differences between buried features and the surrounding sample medium. The scattered acoustic energy will eventually reach the sample surface, and cause a displacement that may be picked up using an AFM probe. As the scattered energy depends on the fourth power of the ultrasound frequency and the sixth power of the feature radius ¹⁵, ultrasonic frequencies > 1 GHz are needed to detect subsurface features with nano- or micrometer sizes. The static force on the cantilever can be low, as the penetration depth is independent of said static force. Experimental results of features buried below 7 microns of photo-resist have been demonstrated in literature ¹⁴.

While in this paper we focus on the second contrast mechanism based on scattering, existing literature is almost exclusively focused on the first contrast mechanism based on visco-elasticity by using much lower ultrasound frequencies. Even though many different excitation schemes and read-out schemes have been proposed to excite the cantilever, such as UFM⁵, AFAM⁷ or RDF-AFUM¹⁶, and different explanations for the origin of contrast are given for some of these techniques, they all typically employ ultrasound between 0.1-10 MHz. By virtue of the scaling of scattered energy by wavelength, as explained above, none of these methods provide contrast based on scattering of the ultrasound. The notable exception is the work by Hu et al.¹⁴ who employ ultrasound at 1 GHz to visualize structures buried micrometers below a sample surface. In this work we replicate and improve upon the experimental setup for scattering based SSPM as published by Hu et al.¹⁴. Figure 1 displays a schematic of such a bottom actuated scattering based SSPM setup.



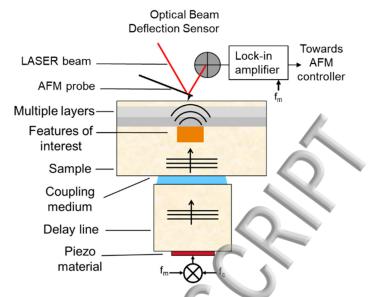


Figure 1 Schematic of a bottom actuated scattering based SSPM setup.

Here, a signal consisting of a carrier frequency (f_c) modulated using a modulation frequency (f_m) is led to a piezo transducer consisting of a piece of piezomaterial and a delay line. The piezomaterial converts the electrical excitation into an acoustic (elastic) wave, which travels through the delay line, the coupling layer, and the sample. The role of the coupling layer is to maximize the transmission of acoustic energy from the delay line into the sample. The coupling layer generally consists of a liquid to ensure no gas bubbles are present in the acoustic beam, as the transmission of sound through a solid - gas / gas - solid interface is poor. Inside the sample, the acoustic wave is scattered by subsurface features. The scattered wave then travels towards the sample top surface, and the resulting sample top surface displacement is picked up by an AFM probe. The contact between tip and sample surface is described in literature by means of Hertz theory ^{8, 12, 17}. In Hertz theory the relation between the contact force and the resulting tip indentation is nonlinear. Therefore the acoustic frequencies that have been scattered towards the sample surface result in a displacement that is downmixed by the nonlinear tip-sample interaction. The analytical expansion of such mixed frequencies shows that the process generates a low frequency component signal at the chosen modulation frequency (or twice the modulation frequency depending on the modulation scheme). Details of the experimental setup relevant for the downmixing are reported in the work by van Es et al.8 Typically the modulation frequency is chosen to be close to the contact resonance frequency of the cantilever (0.1 - 1 MHz) to enhance the AFM sensitivity ¹⁸.

In the case of a 1 MHz modulation frequency and a 1 GHz carrier frequency, a thousand 1 GHz cycles fit in the time length of one 1 MHz cycle. For silicon the wavelength at 1 GHz is ~9.7 µm and the spatial length of a thousand 1 GHz cycles is ~9.7 mm. As the thickness of the transducer and the sample combined is ~1 mm, during operation a complex acoustic interference pattern exists inside the transducer, coupling layer and sample stack. Thus, frequencies exist where constructive interference occurs and frequencies exist where destructive interference occurs. At the carrier frequencies where constructive interference occurs, one may expect the highest sample surface displacements. However, the situation is more complex, as the coupling layer typically has a different acoustic impedance than the delay line and the sample. Because of this separate resonances exist in the transducer, the coupling layer, the sample and all combinations thereof. These resonances overlap and interfere leading to a strong dependence of the sample surface displacement on the geometry and mechanical properties of the transducer, coupling layer and sample. Thus, it is absolutely critical to select the



carrier frequency producing a high sample surface displacement for the particular transducer/coupling layer/sample combination of interest. Moreover, the carrier frequency should be tracked over time or even better the geometry – and especially the liquid coupling layer – should be kept stable for the measurement duration (hours). Thus, there is also a need to monitor the thickness of the coupling layer over time. This can be done using acoustic measurements.

In this work, we present the design of a mechanical clamp system to ensure a stable acoustic coupling and thus to enable practical scattering based SSPM measurements. Moreover, an acoustic method is presented to measure the coupling layer thickness in real-time. Finally, scattering based SSPM measurements are presented.

Wave propagation

The coupling layer

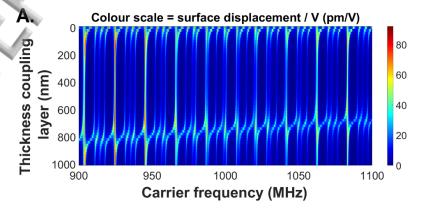
The coupling layer exists to maximize the transmission of acoustic energy from the transducer into the sample. To prevent the presence of gas bubbles in the acoustic beam (the transmission of sound through a solid – gas / gas – solid interface is poor), the coupling layer generally consists of a liquid. The ideal coupling layer liquid should:

- have a low sound attenuation to minimize energy losses in the layer,
- have a low viscosity, such that the layer thickness may be rapidly minimized during mounting with minimal additional force,
- be non-toxic to keep the measurement protocols simple,
- be easily cleanable or leave no residues,
- have a reasonably low evaporation rate.

A number of liquids were evaluated as a coupling layer, and demineralized water was selected. It has a low sound attenuation, ranging from 0.22 dB/ μ m at 1 GHz up 22 dB/ μ m at 10 GHz¹⁵. Its dynamic viscosity is 1.0016 mPa.s¹⁹. It is non-toxic and leaves virtually no residue. Moreover, its evaporation rate is acceptably low.

Wave propagation in the transducer – coupling layer – sample stack

The dependency of the out-of-plane top sample surface displacement as a function of the thickness of the water coupling layer and the carrier frequency was investigated using the KLM model^{20,21}. The results are presented in Figure 2. The acoustic stack consisted of a transducer made up of a ZnO piezolayer resonating at 1 GHz and a 0.45 mm silicon delay line, a coupling layer consisting of water and a 0.7 mm silicon sample (see Figure 1 for a schematic of the stack).





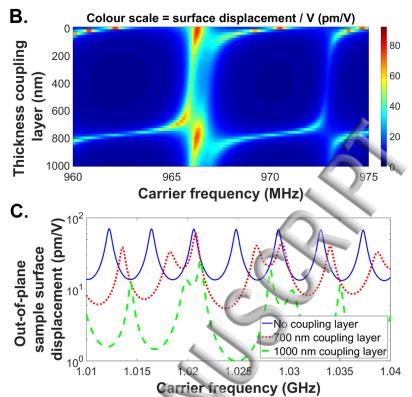


Figure 2 a) Simulated out-of-plane top sample surface displacement per excitation Voltage versus the thickness of the coupling layer and the carrier frequency. The colours indicate the out-of-plane top sample surface displacement in pm. This frequency response was calculated using the 1D KLM mode^{20,21}. The stack consisted of a transducer made up of a ZnO piezolayer resonating at 1 GHz and a 0.45 mm silicon delay line, a coupling layer consisting of water and a 0.7 mm silicon sample (see Figure 1). b) zoom of the figure displayed in a). c) Simulated out-of-plane top sample surface displacement per excitation Voltage for three different coupling layer thicknesses: no coupling layer – solid blue line, 700 nm – dotted red line, 1000 nm – dashed green line.

Figure 2a shows that the out-of-plane top sample surface displacement strongly depends on the thickness of the water layer and the carrier frequency. It appears that there are regularly spaced frequencies, where the sample surface displacement varies minimally. A zoom of Figure 2a displayed in Figure 2b shows that this is in fact not the case: even at the aforementioned frequencies the surface displacement varies significantly as a function of the coupling layer thickness. The line graphs displayed in Figure 2c indicate that the magnitude of the variation in out-of-plane top sample surface displacement at a particular carrier frequency can be 1-2 orders for different coupling layer thicknesses. This is caused by the constructive or destructive interference of the elastic waves propagating in the transducer – coupling layer – sample stack. The downmixed signal picked up by the AFM will vary even more – 2-3 orders of magnitude –, due to its nonlinear relation with the out-of-plane top sample surface displacement. The added variation due to the nonlinear tip-sample interaction depends on the chosen point of operation on the force-distance curve 22 .

For practical coupling layer thicknesses (>100 nm, as there is always some warp present in the sample/transducer delay line) the simulation results showed that the minimum variation in coupling layer thickness to produce a factor 2 variation in out-of-plane sample surface displacement at a single carrier frequency was 20 nm. The best way of achieving such a mechanical stability over a period of hours was deemed to be with mechanical contact between sample and transducer: the coupling layer should be made to be so thin that the peaks of the sample roughness rest on the peaks of the transducer roughness. In that case the coupling layer thickness is determined by the warp and roughness of the transducer – coupling layer / coupling layer – sample interfaces. During an actual



SSPM measurement the out-of-plane sample surface displacement would be maximized using a carrier frequency sweep. In that way variations in sample properties, thicknesses and the transducer-sample contact would be accounted for.

Design of the mechanical clamp

The aim of the mechanical clamp is to ensure a stable coupling layer with a minimal thickness for multiple hours. The minimal thickness is dictated by the warp and roughness of the transducer and sample interfaces. Although a single 2D SSPM scan takes approximately 10-15 minutes, the hour+ long stability requirement comes from the fact that usually multiple measurements suitable for direct comparison are desired. Since the liquid for the coupling layer evaporates, a means of counteracting evaporation of the coupling layer liquid is also needed.

The stability requirement in the z-direction is set to be 20 nm, as the KLM simulations presented in the previous section indicated that this would lead to a less than a factor of 2 variation in out-of-plane sample surface displacement. With the expected highest spatial wavelengths of the standing wave pattern to be in the range of 966 nm (at 10 GHz), a lateral (x,y) stability of the sample's position of 97 nm is deemed sufficient.

Bringing the top surface of the transducer and the bottom surface of the sample together requires alignment in three degrees of freedom: the out-of-plane rotations (Rx and Ry) and the out-of-plane displacement (z) of the two surfaces need to be equal, with the z-direction being along the surface normal. Should both surfaces be ideal surfaces, aligning them in z, Rx, and Ry, results in perfect contact over the full sample/transducer surface. This is not the case, imperfections in both surfaces exist: both the transducer as well as the sample surface possess a non-zero roughness and warp. As a result, the minimum coupling layer thickness that can be achieved is given by the quality of both surfaces.

In order to align both surfaces in z, Rx, and Ry, three spatially separated forces are exerted along the surface normal, thus exerting a net alignment force in z and moment forces in Rx and Ry. These forces are generated by three clamping fingers that press the sample down onto the transducer. The location of these fingers is chosen such that the three forces are exerted directly above the transducer surface, thus preventing tensile stresses in the sample, while leaving room for the AFM tip to access the sample, see Figure 3. Samples could be coated with a soft layer, the plastic deformation of which is not desired. PMMA is chosen as the example soft material for the clamp design. At the end of each finger a sphere is attached, whose radius is chosen such that the maximum required clamp force does not result in plastic deformations of PMMA. While the maximum clamping force is such as to prevent plastic deformation on the sample's potentially soft top layer, the minimum clamping force is determined by the coupling medium's viscosity and evaporation rate. When the clamp presses the sample onto the transducer, it needs to expel the excess water from between the two surfaces. It was found that the higher the viscosity of the coupling medium, the slower the excess is drained, and the longer it takes for a stable situation, i.e. a situation where there exists mechanical contact between sample and transducer, to be reached. Moreover, if it takes too long for the excess coupling medium to be drained, the coupling medium evaporates, thus yielding insufficient or no coupling. Analytical calculations indicated that a minimum force is required to reach a stable situation in a timely fashion.

The sample's in-plane orientation (Rz) and position (x and y) is determined by an external manual positioning mechanism. By outfitting this mechanism with play between the end-effector and sample, the mechanism can be decoupled from the sample during measurements, thus preventing disturbances to be coupled into the sample/AFM during measurements. The stability of the lateral (x,y) position of the sample is determined by the friction between the transducer and sample. Care is



taken that the lateral force that can be transferred onto the sample via the clamping fingers is substantially lower than the friction force between sample and transducer. Thus ensuring that the transducer-sample contact determines the xy-position stability. The limited size of the transducer top surface and the matched transducer delay line and sample (both silicon), results in a calculated lateral thermally induced displacement of 8.1 nm per 1 °C temperature difference between sample and transducer, where worst case temperature variations are expected to be of this magnitude. This results in significantly better lateral stability than the required 97 nm.

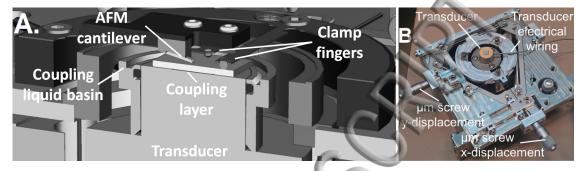


Figure 3 a) CAD drawing of a zoom of the clamp, the transducer – coupling layer – sample stack and the basin. b) The realized clamp including transducer.

Concept of acoustic coupling layer thickness measurement

The induced out-of-plane top sample surface displacement due to the scattering of ultrasound off subsurface features can be low. Moreover, the aforementioned surface displacement varies strongly as a function of the coupling layer thickness. To deal with these variations the carrier frequency should be optimized such that the downmixed signal level at the modulation frequency remains high. Therefore, it is important to monitor the thickness of the coupling layer in real-time. Here, the concept of an acoustic measurement method is discussed. The method uses the GHz transducer already present in the experimental setup (see Figure 1), but utilizes short pulses rather than the continuous wave like excitation used in scattering based SSPM. Moreover, the transducer operates in pulse-echo mode rather than transmission mode.

Traditionally, the thickness of a layer is ultrasonically measured using the time of flight principle. The result is converted into a thickness using the wave speed. An example measurement is shown in Figure 4a, which displays a typical measured pulse-echo time trace recorded of the transducer – coupling layer – sample stack (see Figure 4b for a schematic image of the stack and the travel paths). The green line indicates the interfering echoes produced by the delay line – coupling layer interface and the coupling layer – sample interface. The blue curve indicates echoes originating from the top sample surface. As is clearly visible in Figure 4a, the echoes of the delay line – coupling layer and coupling layer – sample interfaces interfere such that no separate echoes are visible. Thus, to estimate the thickness of the coupling layer the time of flight method is not possible. The cause is the coupling layer thickness, which is in the order of one wavelength (1.5 μ m at 1 GHz in distilled water).



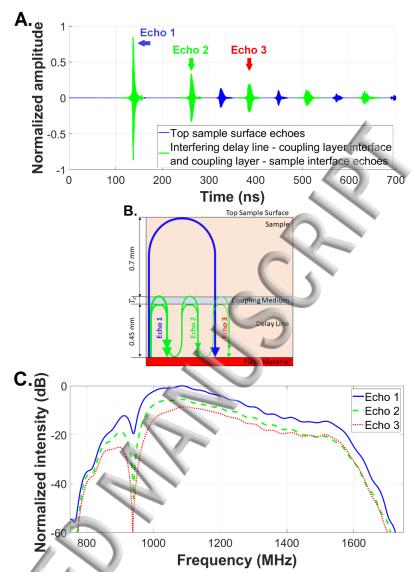


Figure 4 a) Example measurement of a pulse compressed recorded time trace. The setup with which these echoes have been recorded is described in the section 'Experimental setup'. The green line indicates the interfering echoes produced by the delay line — coupling layer interface and the coupling layer — sample interface. The first 3 echoes are indicated. The blue line indicates the echoes coming off the top sample surface. b) A schematic figure detailing the layer stack and the travel path of the first four echoes arriving at the piezomaterial. c) The amplitude spectrum of the Fourier transform of the three echoes indicated by the colored arrows shown in a). The dip at 940 MHz is indicative of the coupling layer thickness, which in this case was 798 nm.

However, in the Fourier spectra of the interfering echoes produced by the delay line – coupling layer interface and the coupling layer – sample interface the aforementioned interference pattern produces distinct dips in their Fourier spectra (Figure 4c). These dips are indicative of frequencies where destructive interference occurs. As the wavelength is ~1.5 μ m at frequencies of ~1 GHz and the transducer and the sample dimensions are >>100 μ m, this is an approximately 1D problem and diffraction effects may be neglected. Also, the attenuation in water is at 0.22 dB/ μ m at 1 GHz very low, and may therefore be neglected as well. Furthermore, the particle displacements are expected to be low, hence nonlinear wave propagation effects may also be neglected. A final assumption is that the acoustic impedance of the coupling layer is either lower or higher than the acoustic impedances of both the delay line and sample. Therefore, for a pulse-echo configuration the resonance dips may be expected at frequencies f_n :





$$f_n = \frac{nc_c}{2T_c},\tag{1}$$

with n the resonance order, T_c the thickness of the coupling layer, and c_c the compressional wave speed in the coupling layer.

For two resonance orders $(f_{n+x} \text{ and } f_n)$ separated by a positive integer number of x resonance orders, the coupling thickness can be derived independently of the resonance order:

$$T_C = \frac{x c_C}{2\Delta_{f_X}},\tag{2}$$

with
$$\Delta_{f_x} = f_{n+x} - f_n$$
.

In order to be able to measure a resonance dip for all relevant coupling layer thicknesses, the measurement system should have an upper frequency bandwidth limit (f_{upper}) defined as:

$$f_{upper} > \frac{c_c}{2T_{min}},\tag{3}$$

With T_{min} the minimal possible mean distance between the top of the transducer and the bottom of the sample as dictated by the warp and roughness of both aforementioned layers.

To ensure that no ambiguity exists on the resonance dip order, the lower frequency bandwidth (f_{lower}) limit of the measurement system should be:

$$f_{lower} \le f_{upper}/3.$$
 (4)

Note that it is assumed here that the sensitive frequency range of the piezotransducer is continuous and smooth.

In liquids the compressional wave speed depends on the temperature and only slightly on the pressure. For distilled water at 20°C and at a pressure of 1 atmosphere the compressional wave speed (c_w) is 1483 m/s 23 , and the temperature dependency of c_w is 3 m/s 23 c around 20 °C.

Experimental setup

Setup description

An arbitrary waveform generator (M8195A, Keysight, Santa Rosa, USA) generated electrical signals, which were amplified by a power amplifier (ZHL-2-8+, Mini-circuits, New-York, USA), and routed through a power splitter (ZFRSC-42-S+, Mini-circuits, New-York, USA). The latter allowed for the monitoring and digitization of the transmitted signal on an oscilloscope (DSA 70804B, Tektronix, Beaverton, USA). The signal was routed through a circulator (PE83CR1013 and PE8432, Pasternack, Irvine, USA) to a piezoelectric transducer (custom designs with center frequencies of 1.1 and 3.1 GHz, Kibero, Saarbrücken, Germany). Return pulse-echo signals were routed by the circulator to the oscilloscope and digitized. The acoustic wave produced by the piezoelectric transducer travelled through the delay line, the coupling layer and the sample and displaced the sample surface. A schematic overview of the aforementioned part of the experimental setup is shown Figure 5.



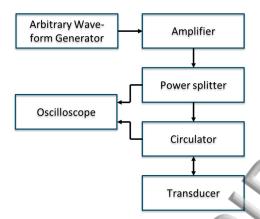


Figure 5 Schematic overview of the experimental setup.

To measure the out-of-plane top sample surface displacement an AFM (Dimension Icon, Bruker) was used. For this the custom built clamp was mounted on the sample stage of the AFM with a dedicated embrace. The AFM probes (SCANASYST-AIR, Bruker Nano Inc., Berlin, Germany) were operated in contact mode at setpoint forces of $10-30\,\mathrm{nN}$. This force setting was chosen as a compromise between the desire to minimize stresses induced by the cantilever tip in the sample (to prevent possible viscoelastic contrast interfering with the scattering based contrast), the desire to maximize the nonlinearity of the tip-sample interaction and the practical need to have robust measurements over a period of hours. The contact resonance frequency of the cantilever was determined using spectra of the thermal motion. For the scattering based SSPM measurements the transducer was excited using an amplitude modulated excitation signal. It consisted of two high frequency sinusoids, the difference of which was close to the first order cantilever contact resonance. The downmixed signal induced by the out-of-plane sample surface displacement was picked up at the contact resonance frequency of the AFM cantilever and measured by the lock-in amplifier (UHFLI Lock-in Amplifier, Zurich Instruments, Zurich, Switzerland). Here, the reference signal was provided by the arbitrary waveform generator. A schematic overview of the experimental setup is shown in Figure 1.

To measure the thickness of the coupling layer the transducer was used in pulse-echo mode. The transmission signals consisted of linear frequency modulated (LFM) pulses with a pulse duration of 50 ns. For the 1.1 GHz transducer LFM pulses with a center frequency of 1.25 GHz and a -3 dB (amplitude) bandwidth of 0.77 GHz were used, whereas for the 3.1 GHz transducer LFM pulses with a center frequency of 3 GHz and a -3 dB (amplitude) bandwidth of 5.7 GHz were used. For each thickness estimate 100 pulse-echo traces were averaged. The pulse repetition frequency was 67 Hz. Different pulse types were required for the scattering based SSPM and the coupling layer thickness measurements. Therefore, the latter measurements were interleaved with the former – the acoustic coupling layer thickness measurements were performed every minute or before and after each AFM scan (scan time typically 5 - 10 minutes).

The setup was located in a temperature controlled room limiting temperature variations to < 0.5 °C. Thus the maximum absolute c_c error of 1.5 m/s led to an absolute thickness estimation error of 0.75 nm.

The sample was a silicon slab with a size of 10x10x0.7 mm³.





Signal processing – acoustic coupling layer thickness measurement

A custom built signal processing algorithm was created to automatically extract the coupling layer thickness from the ultrasonic pulse-echo data. The algorithm performed the following operations on each acquired time trace:

- 1. Time windowing to supress electrical crosstalk and reverberation.
- 2. Band-pass filtering.
- 3. Pulse compression to convert the linear frequency modulated pulses into short pulses and by that enhance the signal-to-noise ratio.
- 4. Automatic extraction of the echoes originating from the delay line coupling layer and the coupling layer sample interfaces (see Figure 4a) in two steps:
 - a. First echo detection using input geometry and thresholding.
 - b. Detection of subsequent 6 echoes using a search algorithm. Here a forward acoustical model was fitted to the measurements and evaluated according to a maximum energy criterion.
- 5. Resonance frequency extraction in three steps:
 - a. A fast Fourier transform (FFT) was performed on each extracted echo (see an example in Figure 4b).
 - b. The result was inverted to change the dips in the spectrum into peaks,
 - c. The result of 5b was detrended,
 - d. The result of 5c was interpolated, where the oversampling factor was computed to match the required accuracy.
 - e. The frequencies of the resonances were extracted automatically using a threshold algorithm. Both the amplitude and phase information was used. The corresponding peak prominences (peak-to-valley ratio's) were also saved as a quality metric.
- 6. The coupling layer thickness was estimated by combining multiple extracted resonance frequency estimations, where the resonances were weighted according to their prominence.

Measurement protocol

The measurement protocol consisted of the following steps:

- 1) Mount the chosen transducer on the clamp.
- 2) Mount the clamp on the sample stage of the AFM.
- 3) Clean the top of the transducer and the bottom of the sample using iso-propanol to remove micrometer sized particles, which could disrupt an optimal acoustic coupling.
- 4) Mount the AFM probe.
- 5) Align the cantilever with the transducer center and use this location as a reference.
- 6) Add a droplet of water (typically $10 \mu l$) on top of the transducer. The droplet volume is chosen to be slightly larger than the coupling layer volume as determined by the warp and roughness of the transducer top surface and sample bottom surfaces.
- 7) Place the sample on top of the transducer top surface.
- 8) Mount the top of the clamp to lock the sample in place.
- 9) Start acoustic monitoring of coupling layer thickness.
- 10) Wait until the coupling layer thickness stabilizes. Here, the criteria are: 1) a coupling layer thickness, which is equal or smaller than the warp/roughness of the top of the transducer surface plus the warp/roughness of the bottom side of the sample, and 2) the coupling layer thickness should vary less than 20 nm over 10 minutes.
- 11) Start the scattering based SSPM measurement.



Results and discussion

Acoustic coupling layer thickness measurements

The coupling layer thickness was continuously acoustically monitored during the scattering based SSPM measurements. Figure 6 shows a typical example coupling layer thickness measurement as a function of time. The black solid curve with crosses indicates the median coupling layer thickness, whereas the dotted and dashed black lines indicate the median +- the standard deviation.

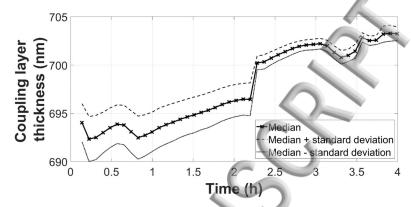


Figure 6 Example measurement of the coupling layer thickness versus time. The black solid curve with crosses indicates the median, whereas the dotted and dashed black lines indicate the median +- the standard deviation.

The results displayed in Figure 6 indicate that in this case a stable coupling layer thickness of 692 – 703 nm was achieved over a period of 4 hours. The standard deviation on the acoustic coupling layer thickness measurements was 0.7 – 2 nm. The smooth upward trend in the data is likely caused by a temperature increase of the coupling layer liquid – a 1°C change in temperature leads to a 1.5 nm apparent coupling layer thickness increase. Part of the temperature change was caused by the 2 -3 °C temperature variation in the room during the day (the measurement took place in the morning), the remainder of the increase is likely due to local heating by the electrical equipment. A jump of about 4 nm was observed in the output coupling layer thickness estimation at a time of ~2.2 hours. This corresponded to the moment in time where extra liquid was added to the basin to counteract evaporation. The aforementioned jump in coupling layer thickness could be caused by:

- 1) a small temperature difference between the added liquid and the transducer/sample. This led to a wave speed difference and therefore to a perceived change in coupling layer thickness.
- 2) The sample shifted slightly with respect to the transducer due to the addition of the liquid, leading to a change in the measured coupling layer thickness.

The practical measurement time without filling the basin was approximately 10-15 minutes. This was caused by the capillary action on the liquid between the sample and the transducer: the water evaporated on the outside of the coupling layer and was pulled to the outside by the capillary effect. When the basin was filled with liquid, the measurement time was extended up to 2+ hours.

SPM measurements

The simulations displayed in Figure 2 predicted an out-of-plane sample surface displacement, which heavily depended on the choice of carrier frequency for a given coupling layer thickness. This was experimentally investigated by measuring the AFM response at a single spatial location, whilst sweeping the carrier frequency. Figure 7 shows the AFM signal amplitude at the downmixed frequency as a function of the carrier frequency for two cases. Figure 7a shows measurement results where the 1.1 GHz transducer was used. The modulation frequency was set to 260 kHz. Figure 7b shows measurement results where the 3.1 GHz transducer was used. Here, the modulation frequency was



set to 250 kHz. For both cases the carrier frequency was swept with 500 kHz steps at a sweep rate of 8 s per step. The GHz transducer excitation Voltage was $^{\sim}6$ V_{pp}.

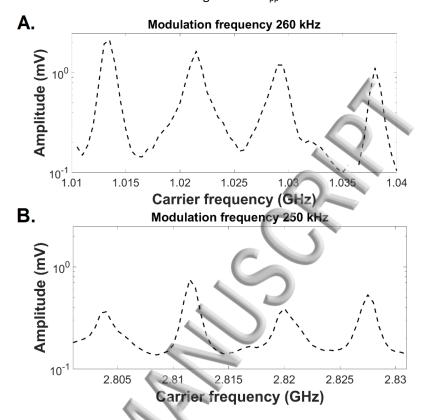


Figure 7 AFM signal amplitude at the modulation frequency induced by sample surface displacement as a function of carrier frequency. a) Measurement results obtained using a 1 GHz transducer. The modulation frequency was set to 260 kHz. b) Measurement results obtained using a 3.1 GHz transducer. The modulation frequency was set to 250 kHz. For both cases the carrier frequency was swept with 500 kHz steps at a sweep rate of 8 s per step. The GHz transducer excitation Voltage was $^{\sim}6 V_{pp}$.

The frequency spacing of the peaks is ~8 MHz for both the cases displayed in Figure 7. Notice that there appear to be 'extra' peaks, eg at 1.018 and 1.032 GHz in Figure 7a and at 2.816 GHz in Figure 7b. The resonance pattern shown in Figure 7a differs from the pattern calculated in Figure 2c. This is caused by the fact that the coupling layer thickness for the measurement in Figure 7a differs from the one in Figure 2c. Moreover, the model used to generate the results displayed in Figure 2c is 1 dimensional, whereas reality is 3D. Since at 1 GHz the mode order is > 125, small deviations due to the fact that the experiment is not truly 1D will lead to changes in the shape and amplitudes of the resonance peaks. The maximum peak to valley ratio is only in the range of 1 order of magnitude in the measurements, as these are limited by the noise.

To confirm that the coupling layer was stable sufficiently long such that multiple AFM scans could be made, the signal amplitude at the downmixed frequency was monitored over longer stretches of time. Figure 8 displays the downmixed signal amplitude versus the time. Figure 8a shows measurement results where the 1.1 GHz transducer was used. The modulation frequency was set to 260 kHz and the carrier frequency was set to 1021 MHz. Figure 8b shows measurement results where the 3.1 GHz transducer was used. The modulation frequency was set to 250 kHz and the carrier frequency was set to 2750 MHz.



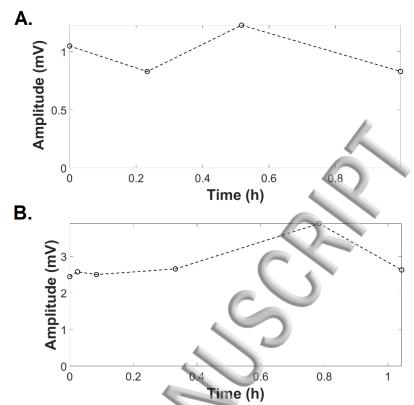


Figure 8 a) AFM signal amplitude at the modulation frequency of 260 kHz as a function of time. The carrier frequency was 1.02 GHz. b) AFM signal amplitude at the modulation frequency of 250 kHz as a function of time. The carrier frequency was 2.75 GHz.

In Figure 8a the downmixed signal amplitude varied between 0.83 and 1.23 mV over a period of slightly less than one hour, whereas in Figure 8b the downmixed signal amplitude varied between 2.44 and 3.89 mV over a period of a bit more than one hour. The aforementioned variance could be caused by not only the variations in the water layer thickness but also slight shifts in the contact resonance frequency due to drift in the probe contact force led by, for instance, variations in ambient temperature and control stability of the AFM setup. Although the signal-to-noise ratio varied slightly over this period, the variance in signal level is acceptably low for successful scattering based SSPM measurements.

Conclusion

The acoustic coupling between the transducer and sample was optimized using a novel clamp design and monitored using the method described in this work. This made scattering based SSPM practical, robust and reliable over a measurement period of hours.

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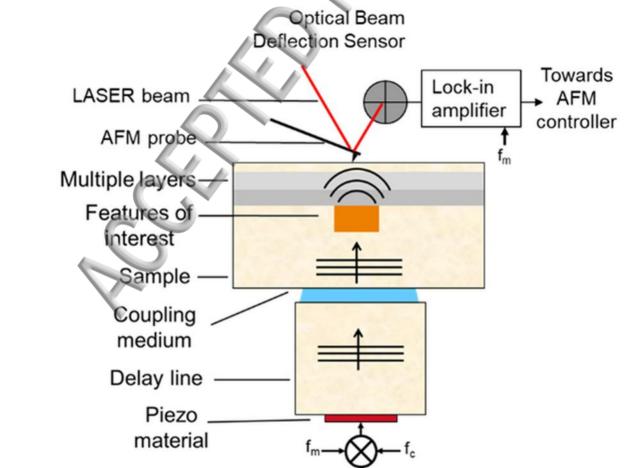
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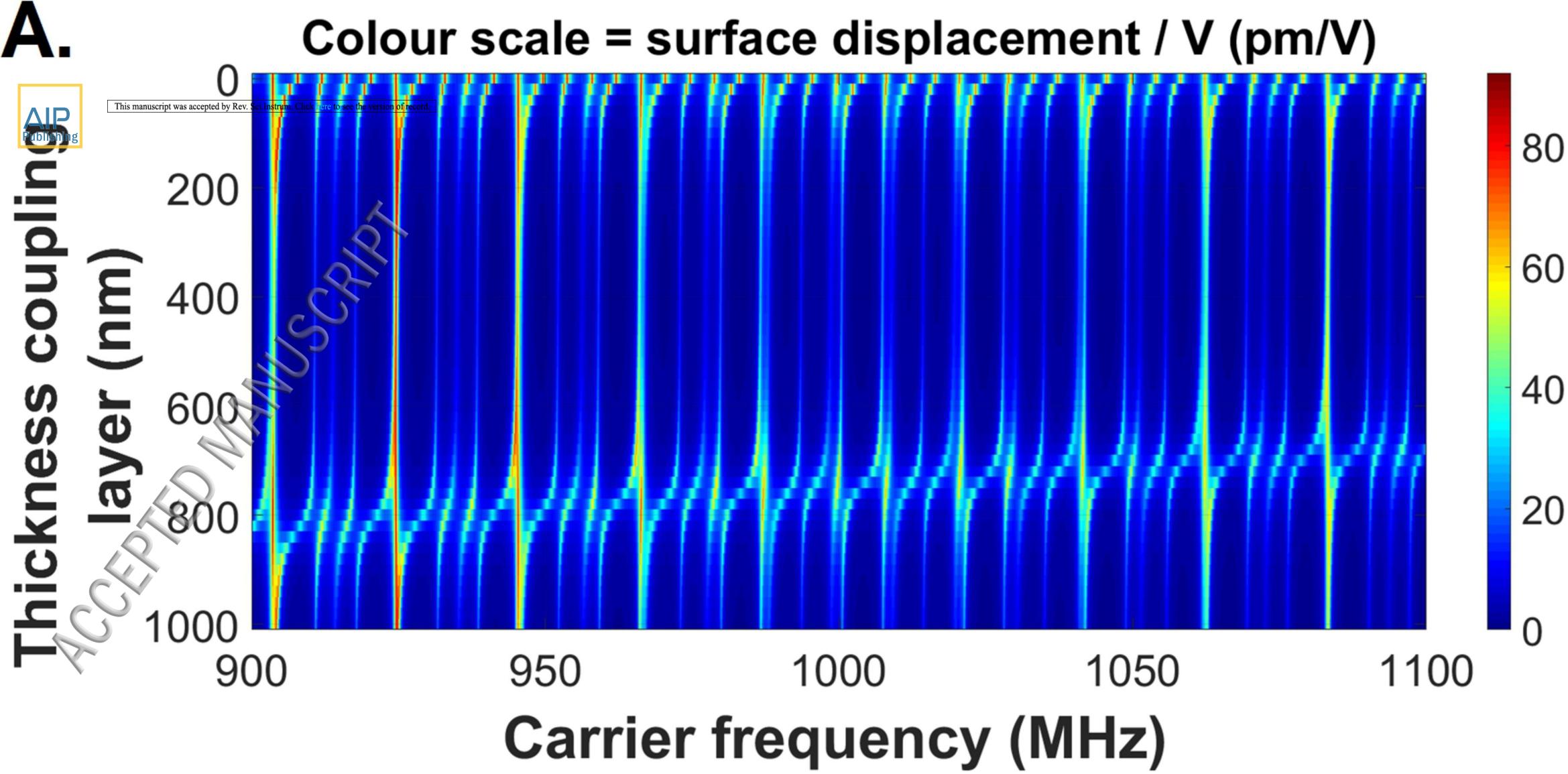


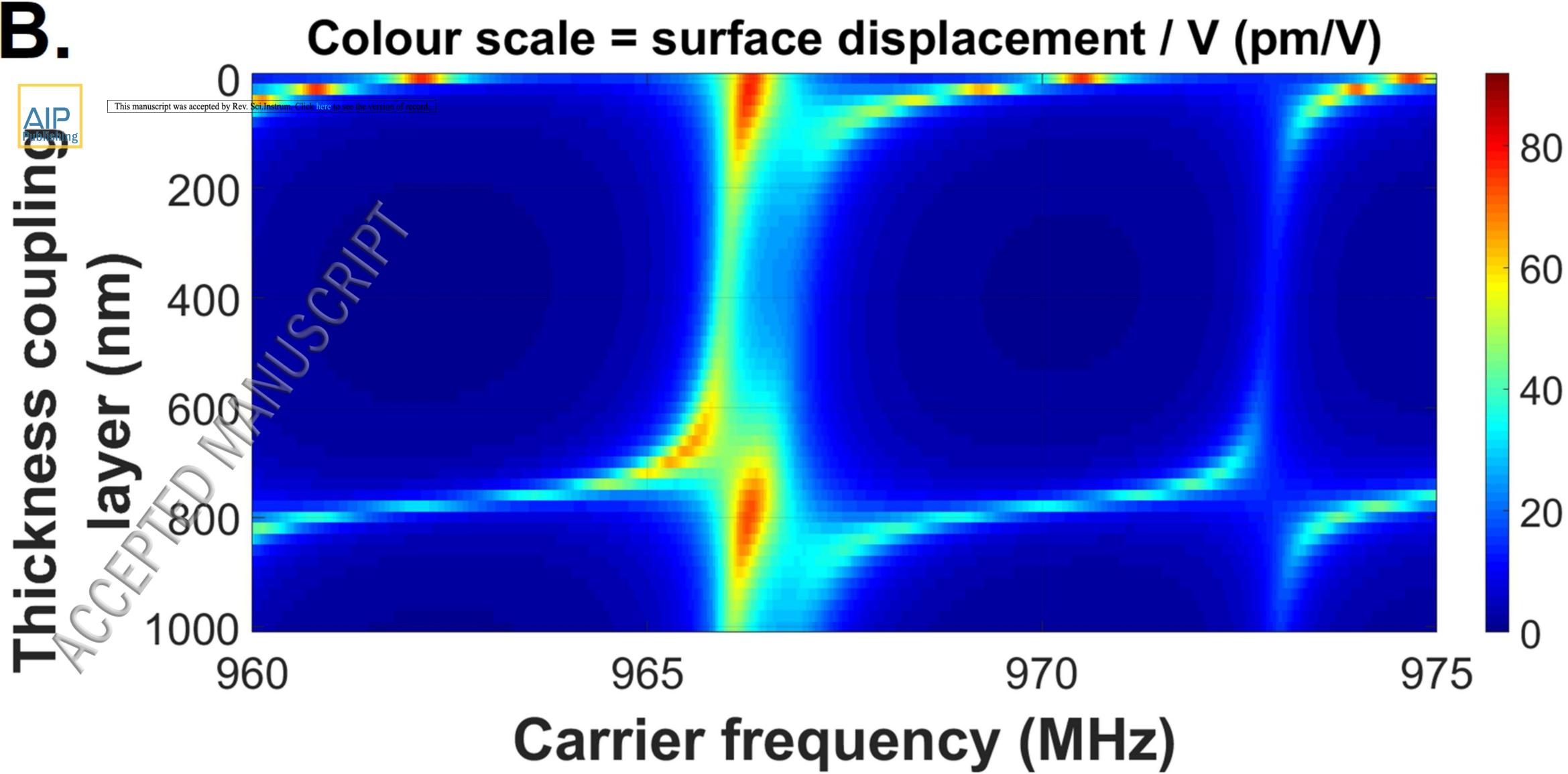
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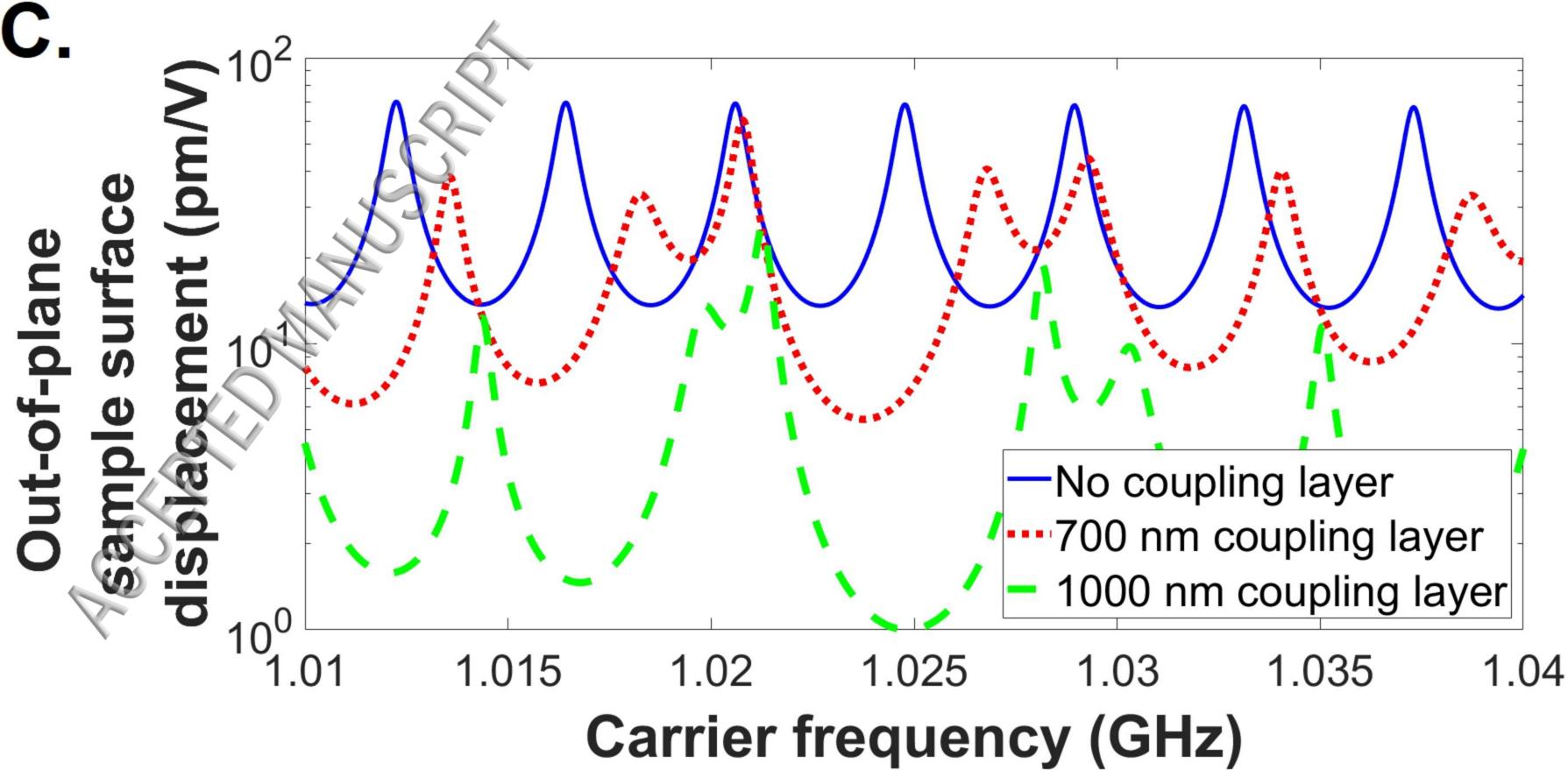


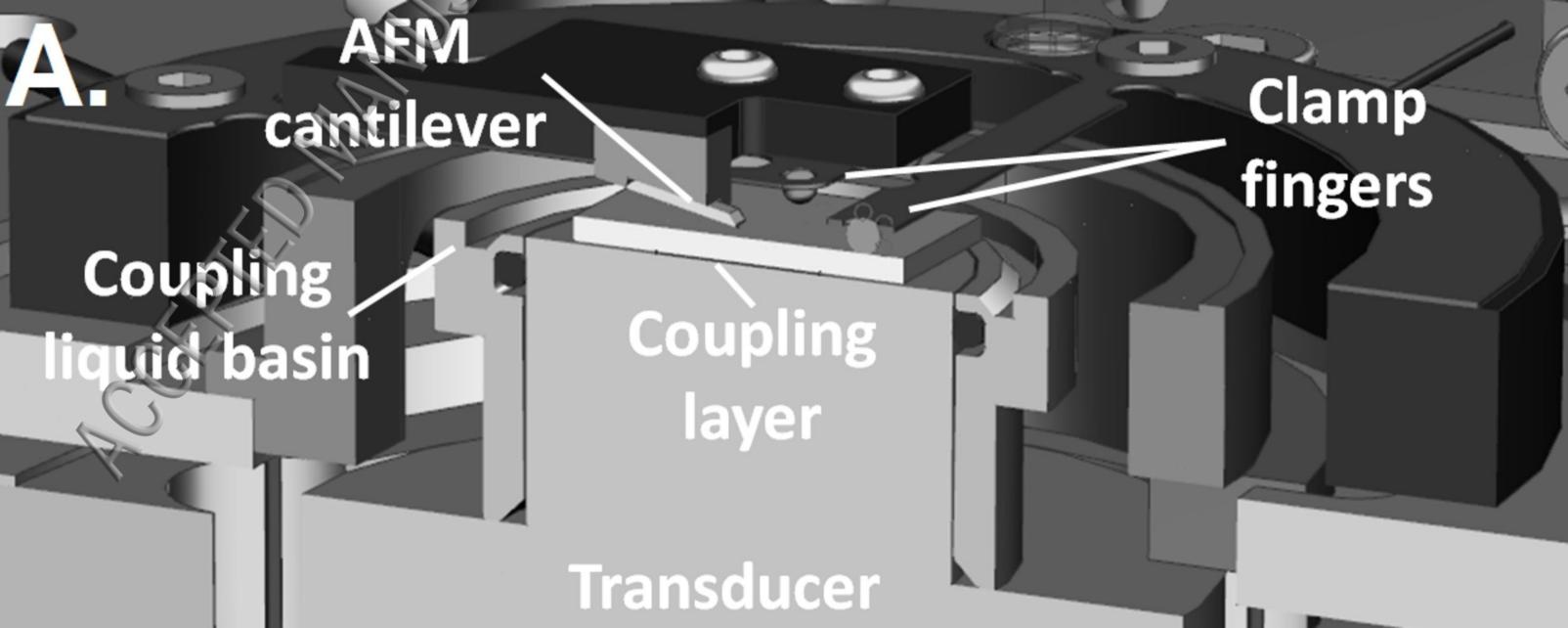
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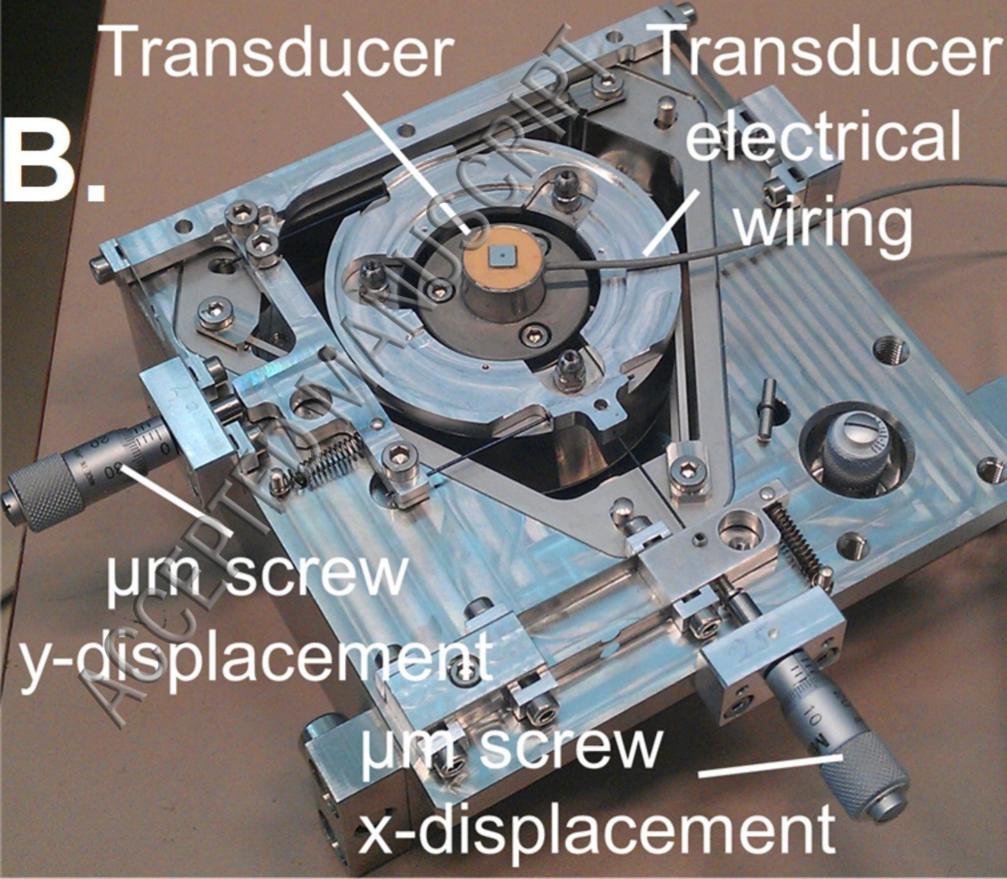


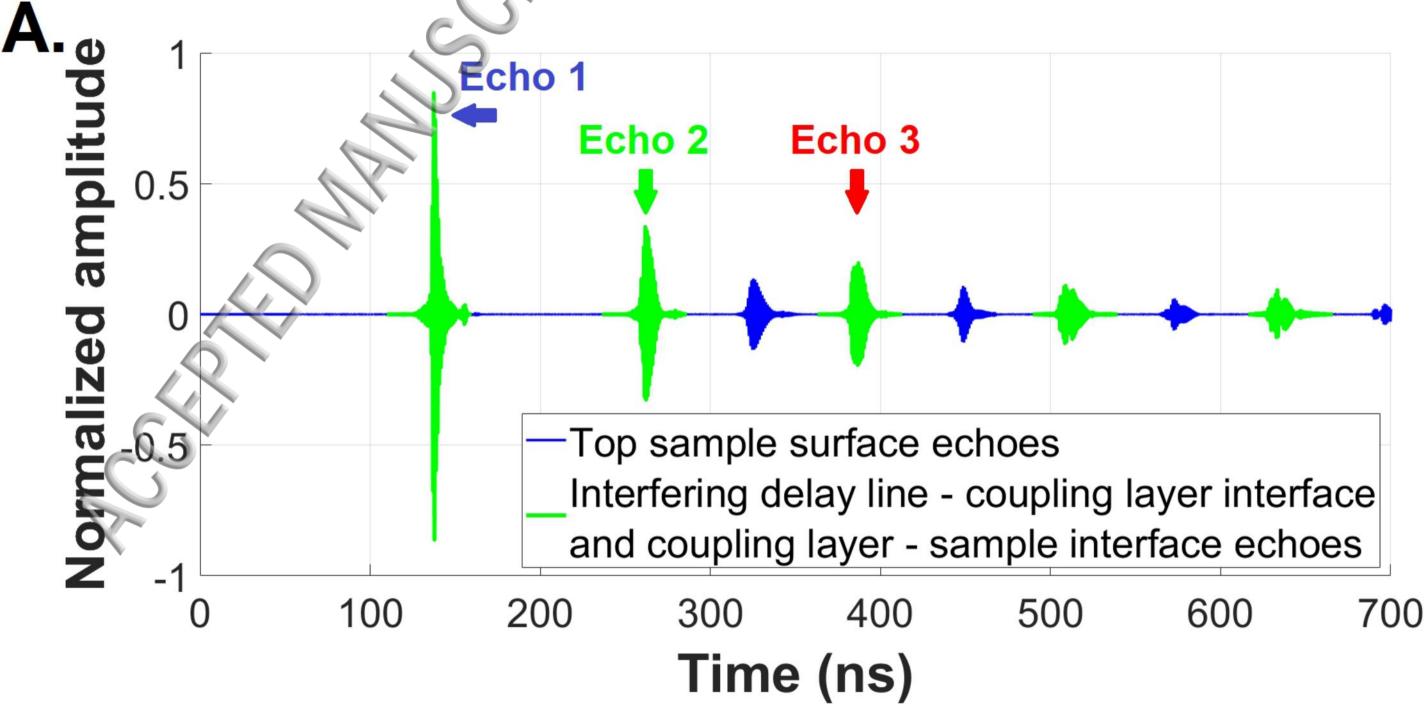


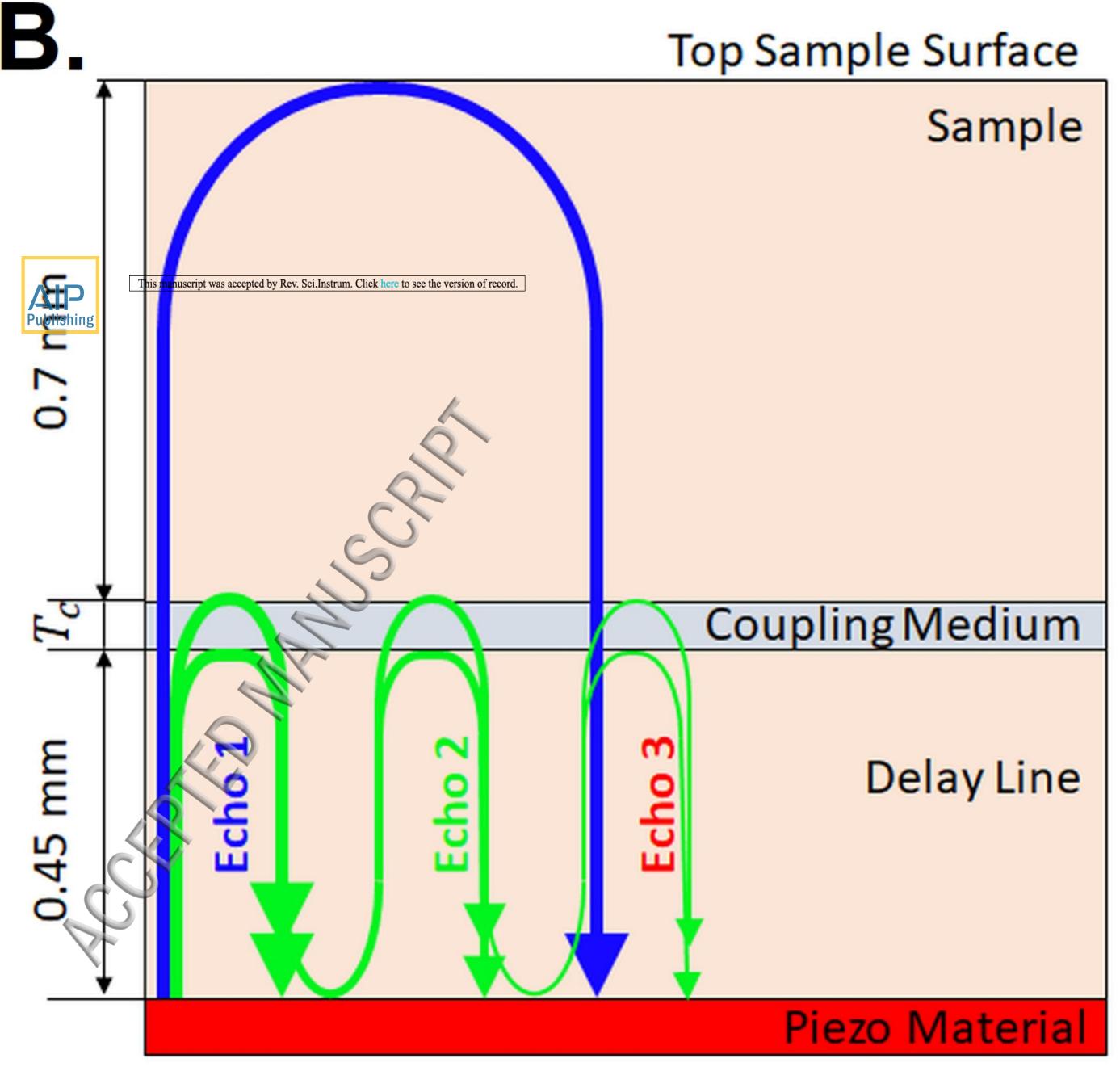


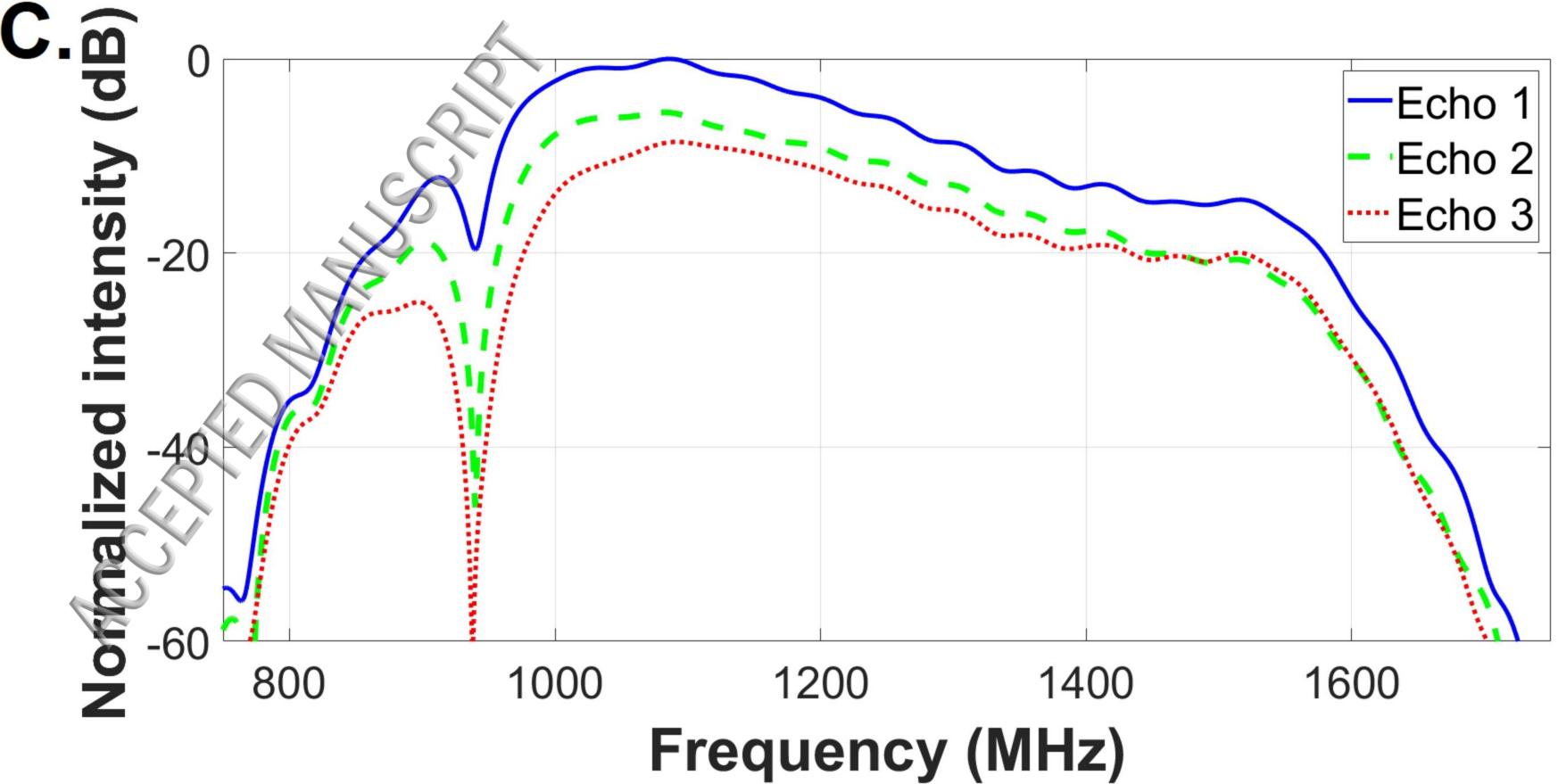


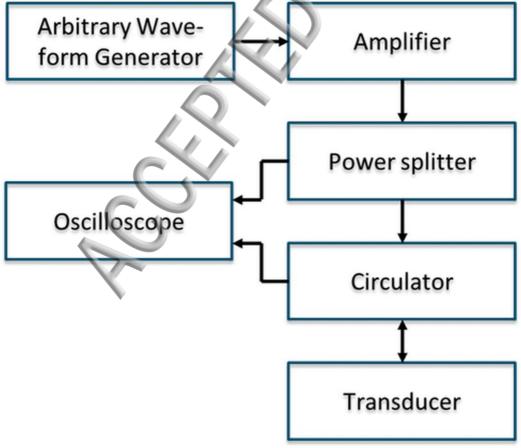


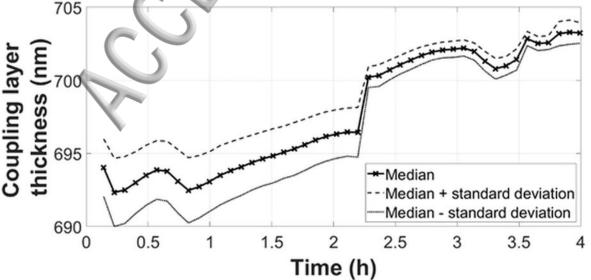


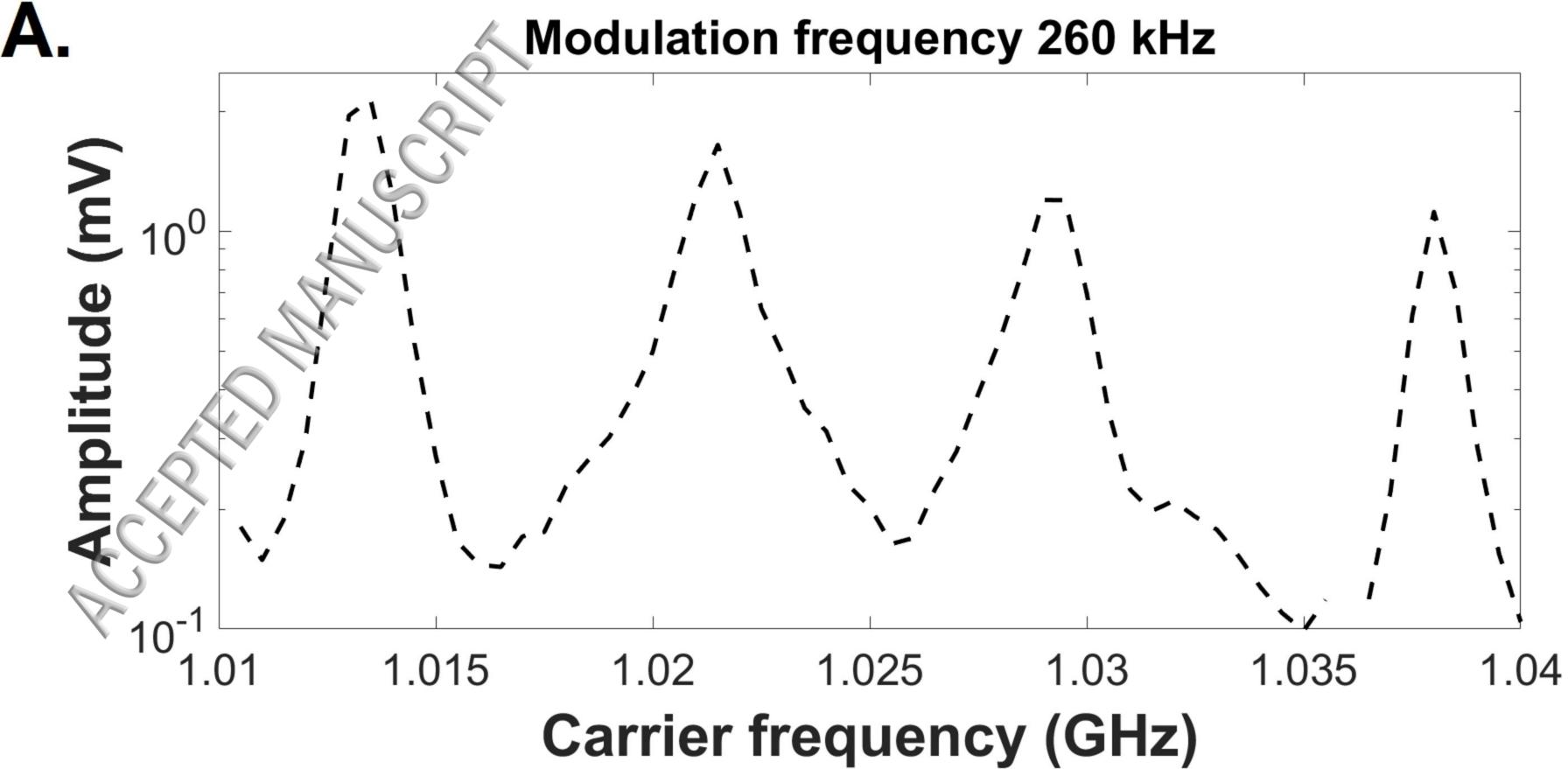


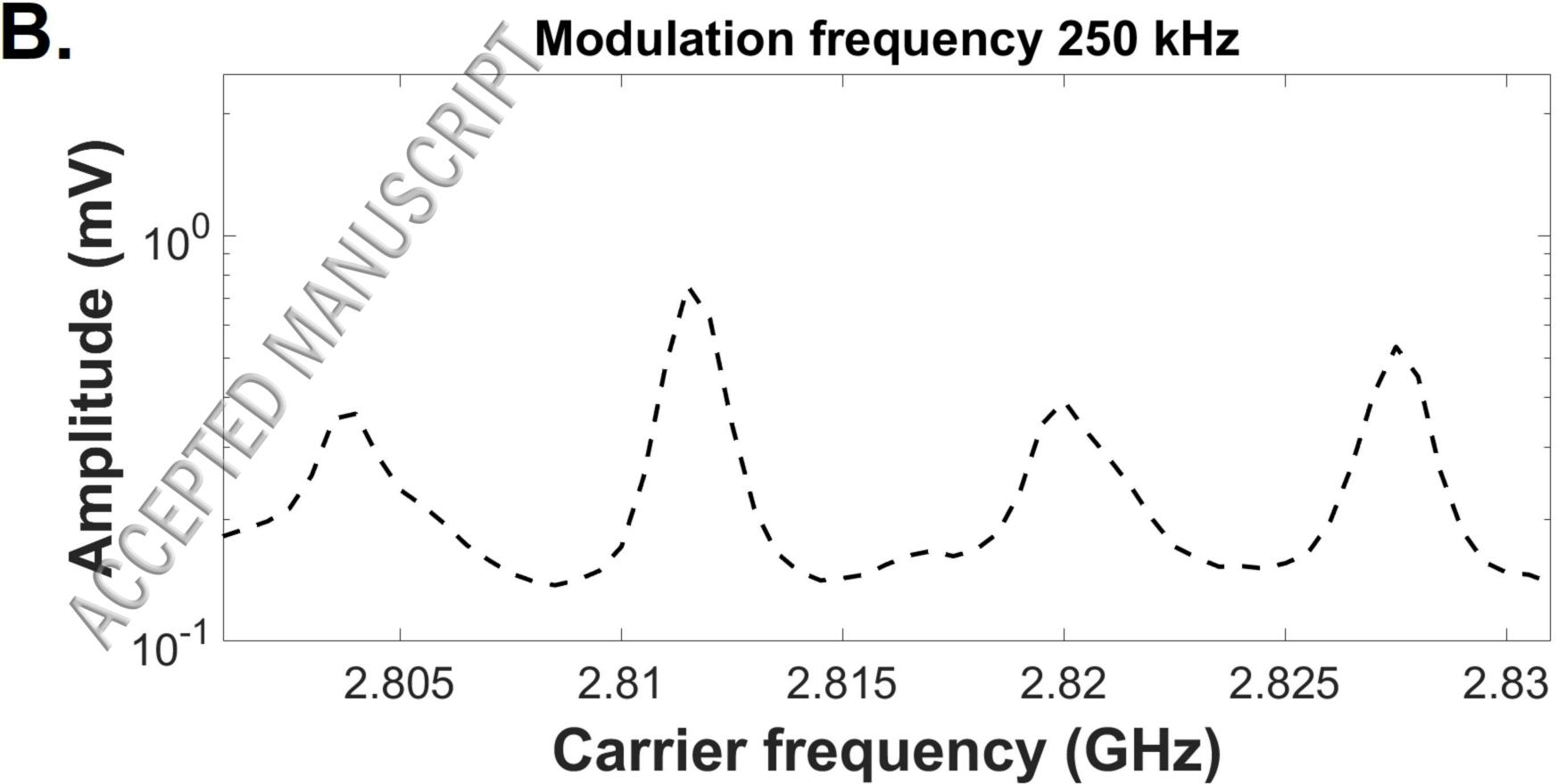


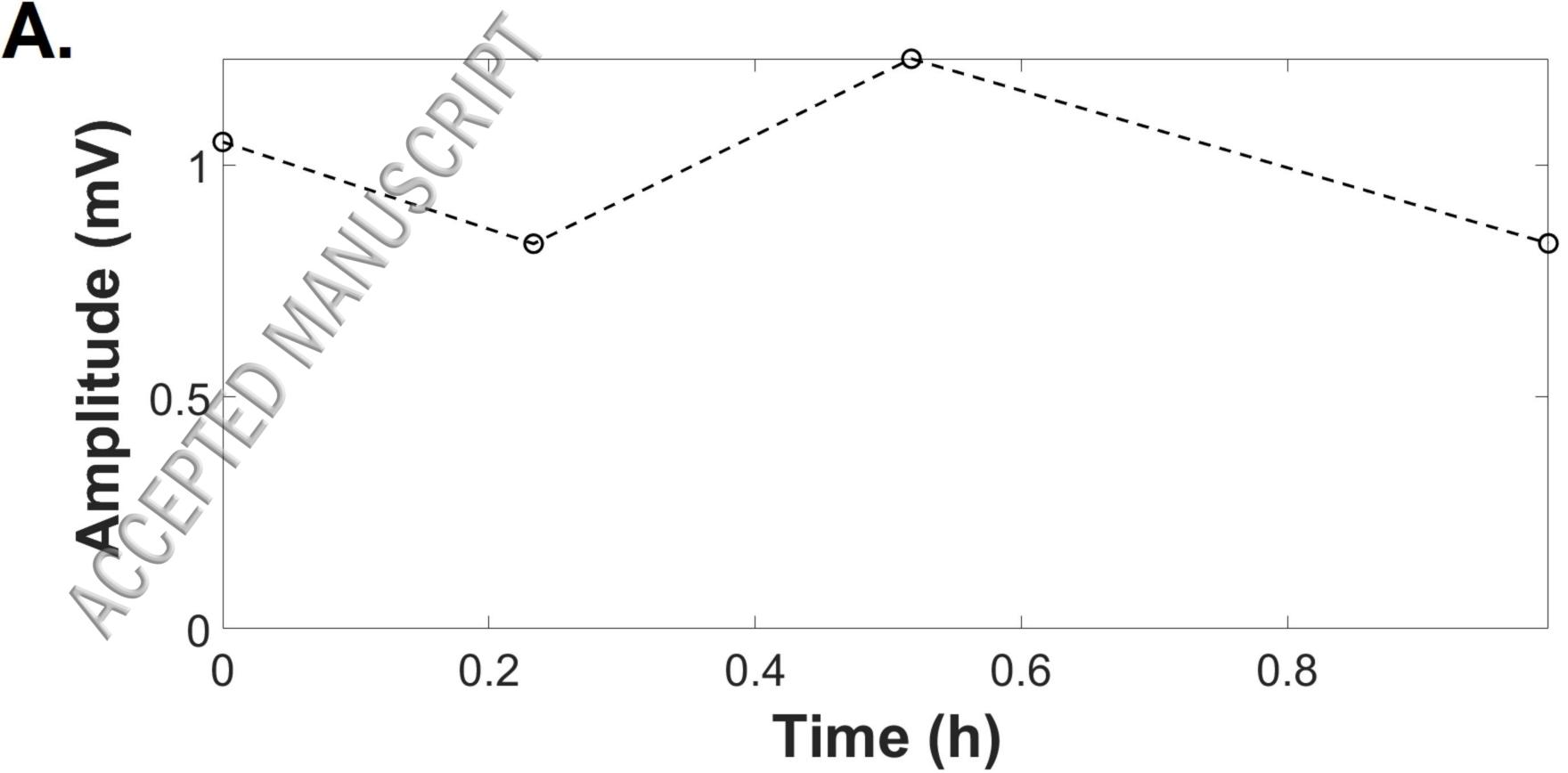












Amplitude (mV) 0.2 0.6 8.0 0.4 Time (h)